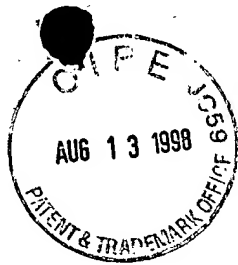


MIT7581L. PAM
RJS10(WP7)
RJS/pjc
August 11, 1998



PATENT APPLICATION
Attorney's Docket No.: MIT-7581L

Pre-a
Wanda
11/16/98

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Joseph B. Bernstein and Zhihui Duan
Application No.: 08/825,808 Group: 1104
Filed: April 3, 1997
For: LASER-INDUCED CUTTING OF METAL INTERCONNECT

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231	
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Date	Signature
<u>Joseph B. Bernstein</u>	
Typed or printed name of person signing certificate	

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PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

Please amend the application as follows:

In the Specification

In a new paragraph preceding "BACKGROUND OF THE INVENTION", insert:

--GOVERNMENT SUPPORT

This invention was made with government support under Contract number F19628-95-C-0002, awarded by the United States Air Force. The government has certain rights in the invention.--

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